

03500.015730.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
TAKASHI IWAKI ET AL.) : Examiner: P. Macchiarolo
Application No.: 09/941,782) : Group Art Unit: 2879
Filed: August 30, 2001) : Confirmation No.: 7656
For: ELECTRON-EMITTING DEVICE,)
ELECTRON SOURCE AND :
METHOD FOR)
MANUFACTURING :
IMAGE-FORMING APPARATUS) July 13, 2007

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SUBMISSION OF FOREIGN COMMUNICATION

Sir:

The Examiner's attention is directed to the attached European Communication issued by a foreign patent office in a foreign counterpart of the present application. The references cited in the European Official Communication were cited in previous Information Disclosure Statements in the present application. Accordingly, no further copies of the cited documents are submitted herewith.

Entry hereof is respectfully requested.

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



Frank A. DeLucia
Attorney for Applicants
Registration No.: 42,476

FITZPATRICK, CELLA, HARPER & SCINTO
30 Rockefeller Plaza
New York, New York 10112-3800
Facsimile: (212) 218-2200